

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/753,220
Filing Date: 01/07/2004
Applicant: Lutz Aschke et al.
Group Art Unit: 1756
Examiner: Stephen Rosasco
Title: Substrate For The Micro-Lithography And Process
Of Manufacturing Thereof
Attorney Docket: 4965-000170

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

In response to the Office Action mailed November 3, 2006, please amend the application as follows and consider the remarks set forth below.

Applicant hereby petitions under the provisions of 37 C.F.R. § 1.136(a) for a one-month extension of time in which to respond to the outstanding Office Action and includes a fee as set forth in 37 C.F.R. § 1.17(a) with this response for such extension of time.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 8 of this paper.